

Table of Contents

Preface	
Part A: In the Beginning	1
Part B: Technical Context of Silicon Nitride Formation	19
Part C: Si₃N₄ Products, Uses and Markets	137
Part D: Si₃N₄ by Reaction of Si(cr) Surfaces and N-Species	247
Part E: Si₃N₄ Powder Formation from Si(Powder)/N₂(g)	341
Part F: Fabrication of Reaction Bonded Silicon Nitride	393
Part G: Si₃N₄ from Si/N₂ under Vigorous Conditions	489
Part H: Si₃N₄ Formation by Reaction of Si with N-Compounds	539
Part I: Si₃N₄ by Nitridation of Si-O Based Materials	589
Part J: Si₃N₄ Formation from Si-N Based Materials	677
Part K: Comparative Overview and Summary of Si₃N₄ CVD	713
Part L: Si₃N₄ by CVD Nitridation of Si-H Compounds	755
Part M: Si₃N₄ by CVD Nitridation of Si Halides and Halosilanes	849
Part N: Si₃N₄ Formation in Si-C-N Systems	935
Part O: Si₃N₄ Formation in Si-N-X Systems, X = B, P, S, Fe, other	981